

Electronic Acknowledgement Receipt

EFS ID:	1162721
Application Number:	10821438
Confirmation Number:	1354
Title of Invention:	Sidewall spacer for semiconductor device and fabrication method thereof
First Named Inventor:	Rong-Hui Kao
Customer Number:	47390
Filer:	Daniel R. McClure
Filer Authorized By:	
Attorney Docket Number:	252011-2210
Receipt Date:	20-AUG-2006
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Application Type:	Utility
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment - After Non-Final Rejection	00413256.pdf	158290	no	12

Warnings:**Information:****Total Files Size (in bytes):**

158290

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.